

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
ASMMC.036AUSAPPLICATION NO.
09/975,466INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(USE SEVERAL SHEETS IF NECESSARY)

APPLICANT
Sophie et al.FILING DATE
October 9, 2001GROUP
2813EXAMINER
INITIAL

OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

EK

1.

Yagishita et al., "Cleaning of Copper Surface Using Vapor-Phase Organic Acids," Materials Researching Society Spring 2003 Meeting, Symposium E, Session E, Paper E3.28

W:\DOCS\ANM\ANM-5580.DOC
071103RECEIVED
JUL 29 2003
TC 2800 MAIL ROOM

EXAMINER

Eric Kach

DATE CONSIDERED

12/13/03

*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.